Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/750,465	CHEN, NIEN-TSU	
Examiner	Art Unit	

Mike Fatahiyar

2629

	SEARCHED				
Class	Subclass	Date	Examiner		
345	156-184	4/28/2007	MF		
341	35	4/28/2007	MF		
200	11R-11TW	4/29/2007	MF		
463	36-39	4/29/2007	MF		

INT	INTERFERENCE SEARCHED		
Class	Subclass	Date	Examiner
} ,			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST search	4/28/2007	MF		